



00862.022170

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Haruhiro ONO et al.) : Examiner: D. Vanore
Application No.: 09/819,907) : Group Art Unit: 2881
Filed: March 29, 2001) :
For: ELECTRON OPTICAL SYSTEM,) : August 25, 2003
CHARGED-PARTICLE BEAM EXPOSURE) :
APPARATUS USING THE SAME, AND) :
DEVICE MANUFACTURING METHOD) :
Commissioner for Patents
Washington, D.C. 20231

AUG 27 2003
TC 2800 MAIL ROOM

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LETTER SUBMITTING CORRECTED PTO-1449 FORM

Sir:

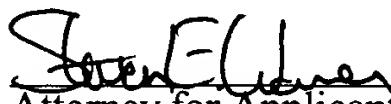
In reviewing the above-identified application, Applicants have noticed an error in the Notice of Art Cited by Applicant (PTO-1449 form) attached to the Information Disclosure Statement filed on July 25, 2003. Specifically, U.S. patent application publication number “2002/0054690 A1” listed on the PTO-1449 form should read -- 2001/0054690 A1 --. Accordingly, Applicants submit herewith a corrected PTO-1449 form.

Applicants request that the information cited in the above-noted Information Disclosure Statement be considered and that a copy of the enclosed corrected PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee under 37 CFR 1.97(c)(2) is believed to be due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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SEW/eab